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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	10/028,288
				Filing Date	December 28, 2001
				First Named Inventor	James A. Tatum
				Art Unit	2814
				Examiner Name	W. Louie
Sheet	1	of	1	Attorney Docket Number	H0002312

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
WSL	AA	US-5,222,002-A	05-28-1996	Chun et al.	
	AB	US-5,940,562-A	08-17-1999	Henson et al.	
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	AD	US-5,068,869	11-26-1991	Wang et al.	
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Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	MM-DD-YYYY			
WSC ↓	BA	EP-0 630 174 A1	12-21-1994	International Business Machines		
	BB	EP-0 630 174 B1	05-25-1994	International Business Machines		
	BC	EP-0 550 996 A1	07-14-1993	Crystallume		
	BD	JP-09223848	08-26-1997	Nippon Telegraph & Tel. Corp.		
	BE					

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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
WSL	CA	"Fundamental Study of Parallel Modulating Scheme Based on a Micro-Optical Bench and Collimating Planar Microlenses," Yasuhiko Aoki et al., Japanese Journal of Applied Physics, Publication Office Japanese Journal of Applied Physics, Tokyo, Japan, Vol. 39, No. 3B, March 2000, pp. 1529-1532	
	CB	"Highly Uniform Vertical-Cavity Surface-Emitting Lasers Integrated with Microlens Array," S. Eitel et al., IEEE Photonics Technology Letters, IEEE Inc., New York, Vol. 12, No. 5, May 2000, pp. 1041-1135	
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	CD	"Manufacturability of VCSEL Components and VCSEL Products," Jim A. Tatum et al., Lasers and Electro-Optics Society Annual Meeting, IEEE Orlando, Florida, December 1, 1998, pp. 409-410	

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Examiner Signature		Date Considered	3/19/04
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DC:50233067.1